



Image
Op 2877
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

JAMES BROC STIRTON
KEVIN R. LENSING
HORMUZDIAR E. NARIMAN
STEVEN P. REEVES

Group Art Unit: 2877

Examiner: Roy M. Punnoose

Atty. Dkt. No.: 2000.092400/TT5002

Customer No.: 23720

Serial No.: 10/084,987


Filed: February 28, 2002

For: METHOD OF USING HIGH YIELDING
SPECTRA SCATTEROMETRY
MEASUREMENTS TO CONTROL
SEMICONDUCTOR MANUFACTURING
PROCESSES, AND SYSTEM FOR
ACCOMPLISHING SAME

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

CERTIFICATE OF MAILING 37 C.F.R. 1.8	
I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:	
November 24, 2003 Date	 Signature

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, it is respectfully requested that this Supplemental Information Disclosure Statement be entered and the documents listed on attached Form PTO-1449 be considered by the Examiner and made of record. Copies of the listed documents required by 37 C.F.R. § 1.98(a)(2) are enclosed for the convenience of the Examiner.

In accordance with 37 C.F.R. §§ 1.97(g),(h), this Supplemental Information Disclosure Statement is not to be construed as a representation that a search has been made, and is not to be

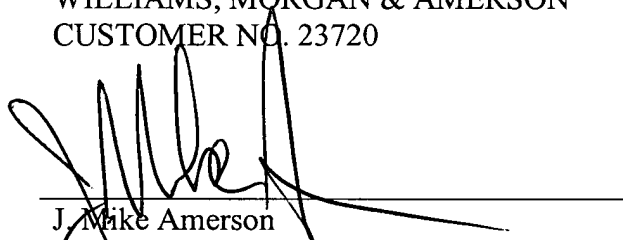
construed to be an admission that the information cited is, or is considered to be, material to patentability as defined in 37 C.F.R. § 1.56(b).

In accordance with 37 C.F.R. § 1.97(e)(1), Applicants hereby certify that each item of information contained in this Supplemental Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the present statement, as evidenced by the date of the enclosed search report.

Applicants respectfully request that the listed documents be made of record in the present case.

Respectfully submitted,

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Date: November 24, 2003

ATTORNEY FOR APPLICANTS

Form PTO-1449 (modified)



Atty. Docket No.

2000.092400/TT5002

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List of Patents and Publications for Applicant:
SUPPLEMENTAL
 INFORMATION DISCLOSURE STATEMENT

Applicant

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Group:

2877

(Use several sheets if necessary)

U.S. Patent Documents

See Page 1

Foreign Patent Documents

See Page 1

Other Art

See Page 1

U.S. Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Name	Class	Sub Class	Filing Date of App.
	A1						
	A2						
	A3						
	A4						
	A5						

Foreign Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Country	Class	Sub Class	Translation Yes/No
	B1	EP 0 727 715 A1	8/21/96	Europe	G03F	7/20	Yes
	B2	WO 01/23871 A1	4/05/01	PCT	G01N	21/95	Yes
	B3	WO 99/45340	9/10/99	PCT	G01B	11/02	Yes

Other Art (Including Author, Title, Date Pertinent Pages, Etc.)

Exam. Init.	Ref. Des.	Citation
	C1	Pfützner <i>et al.</i> , "Cost reduction strategies for wafer expenditure," <i>Microelectronic Engineering</i> , 56:61-71, 2001
	C2	
	C3	

EXAMINER:

DATE CONSIDERED:

EXAMINER: INITIAL IF REFERENCE CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED. INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.